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## BIB DATA SHEET

CONFIRMATION NO. 9283

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/573,492	05/15/2006 RULE	438	2892	8074-1143		
<b>APPLICANTS</b> Koichi Naniwae, Tokyo, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/12146 09/24/2003 <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 10/12/2006						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance Initial	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 16	TOTAL CLAIMS 48	INDEPENDENT CLAIMS 8
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and Acknowledged	/ERIC W JONES/ Examiner's Signature					
<b>ADDRESS</b> YOUNG & THOMPSON 209 Madison Street Suite 500 ALEXANDRIA, VA 22314 UNITED STATES						
<b>TITLE</b> Method of cleaning treatment and method for manufacturing semiconductor device						
<b>FILING FEE RECEIVED</b> 3430	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
				<input type="checkbox"/> 1.16 Fees (Filing)		
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